

#12/12/2002

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant : Raaijmakers et al. ) Group Art Unit 2812  
 App. No. : 09/764,711 )  
 Filed : January 18, 2001 )  
 For : METHOD OF DEPOSITING )  
 SILICON WITH HIGH STEP )  
 COVERAGE )  
 )  
 Examiner : Angel Roman

INFORMATION DISCLOSURE STATEMENT

United States Patent and Trademark Office  
 P.O. Box 2327  
 Arlington, VA 22202

Dear Sir:

Enclosed is form PTO-1449 listing 6 references that are also enclosed. This Information Disclosure Statement is being filed within three months of the filing date of this application or upon filing if this is a CPA or RCE, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: December 2, 2002

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